

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

BRYAN P. STAKER, et al.

Application No.: Unassigned

Filed: Herewith

For: MEMS STRUCTURE WITH  
MECHANICAL OVERDEFLECTION  
LIMITER

Examiner: Unassigned

Technology Center/Art Unit: Unassigned

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please enter the following amendments and remarks:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.